



SiC Megawatt Technology Annual Briefing

October 17, 2000

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Agenda



- Overview
- Process Development
 - JTE
 - Devices
 - Diodes
 - GTOs
 - JFETs
- Package Development
 - SPCO Package Approach
 - K Technology TPG encapsulated material
- CHPS applications

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Megawatt Program Objectives



- Develop SiC Power GTO, JFETs and pn junction diodes with capability up to 5000V/1000A for use in Utility Power Systems
- Achieve intermediate goals of 1kV/5A devices to support Combat Hybrid Power Systems Flywheel Inverter construction
- Initiate the development of a packaging approach for a 5kV/200A package

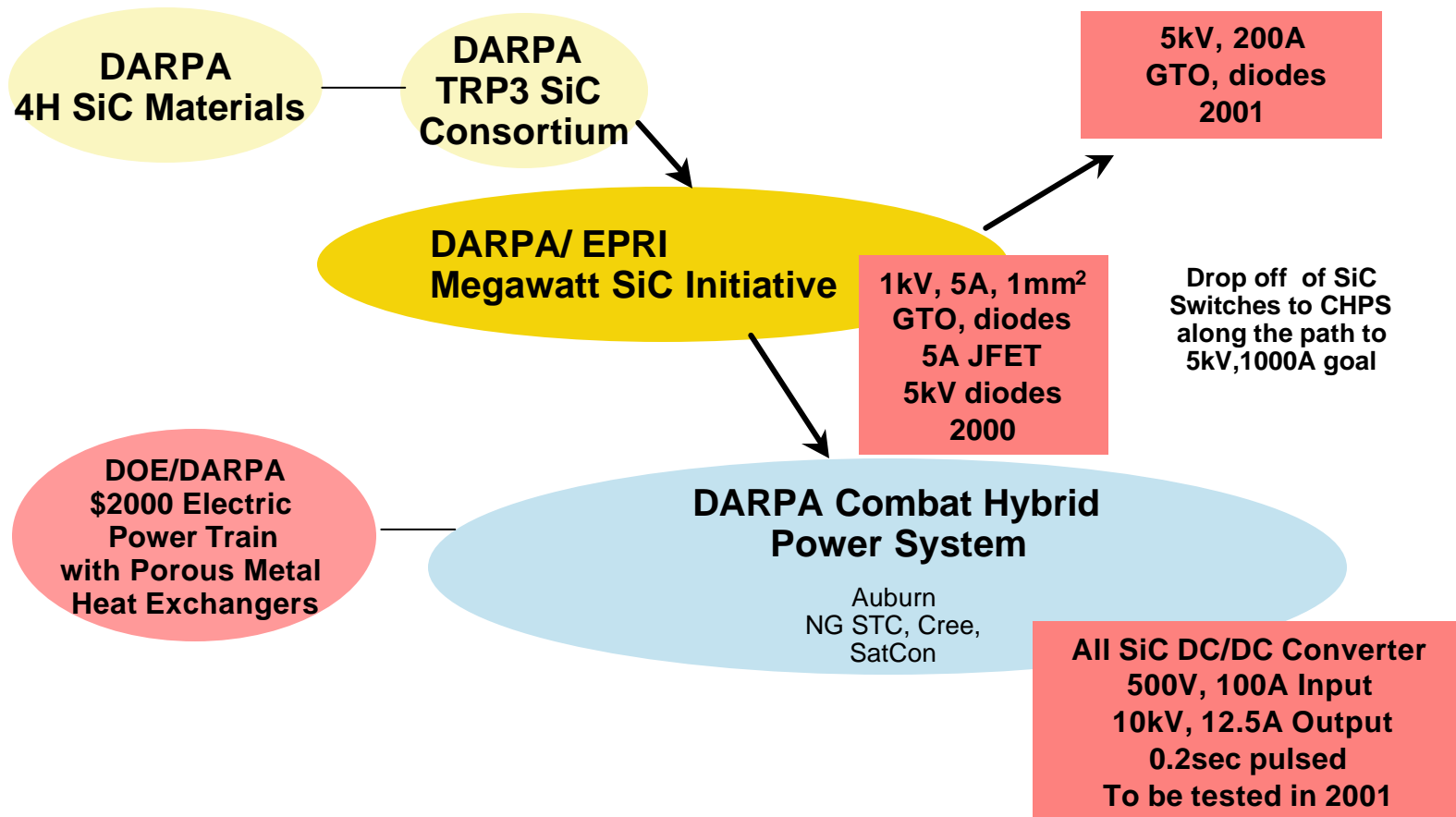
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SiC Evolution



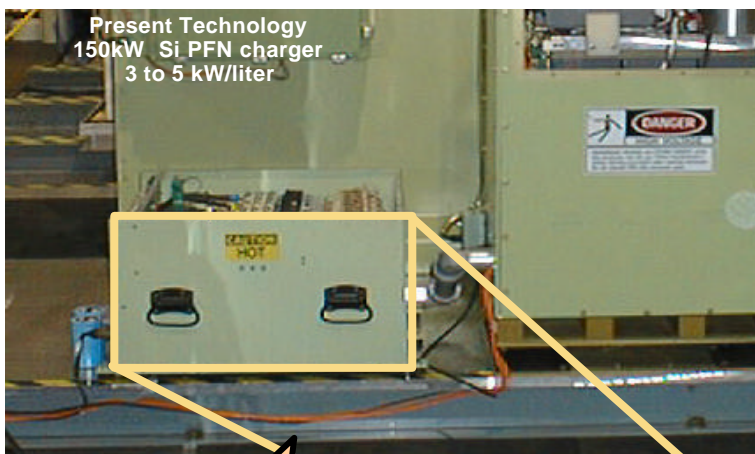
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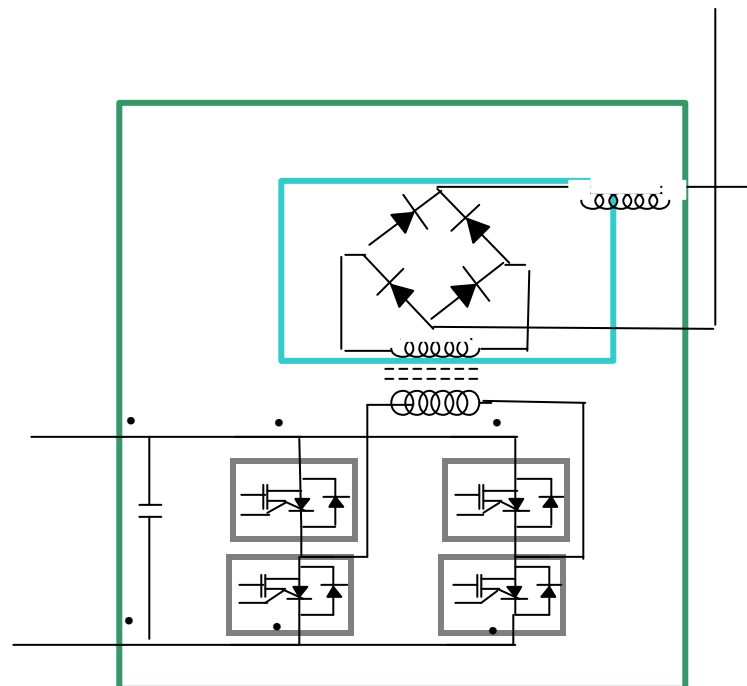
SiC DC/DC Converter demonstrates merits of higher frequency and temperature



**50 kW/liter
10 X Size
Reduction**



**Technology
Impact**



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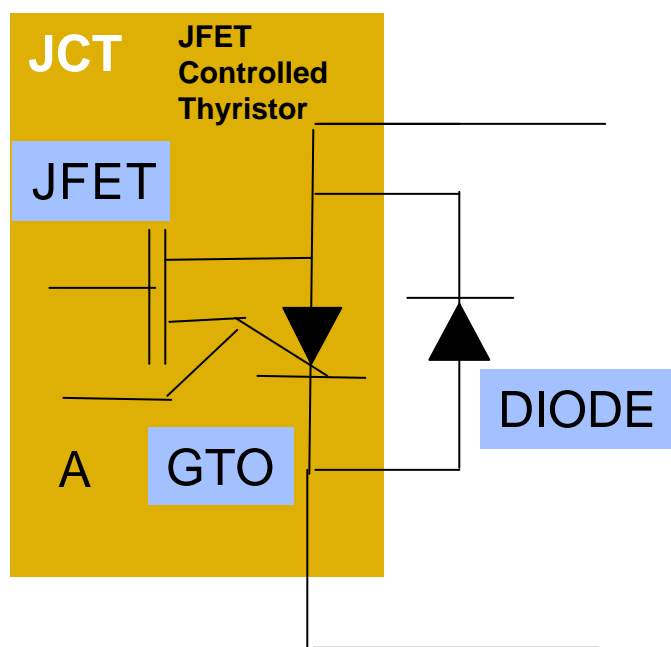
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Building blocks for high power converters and Utility power handling applications

EPRI



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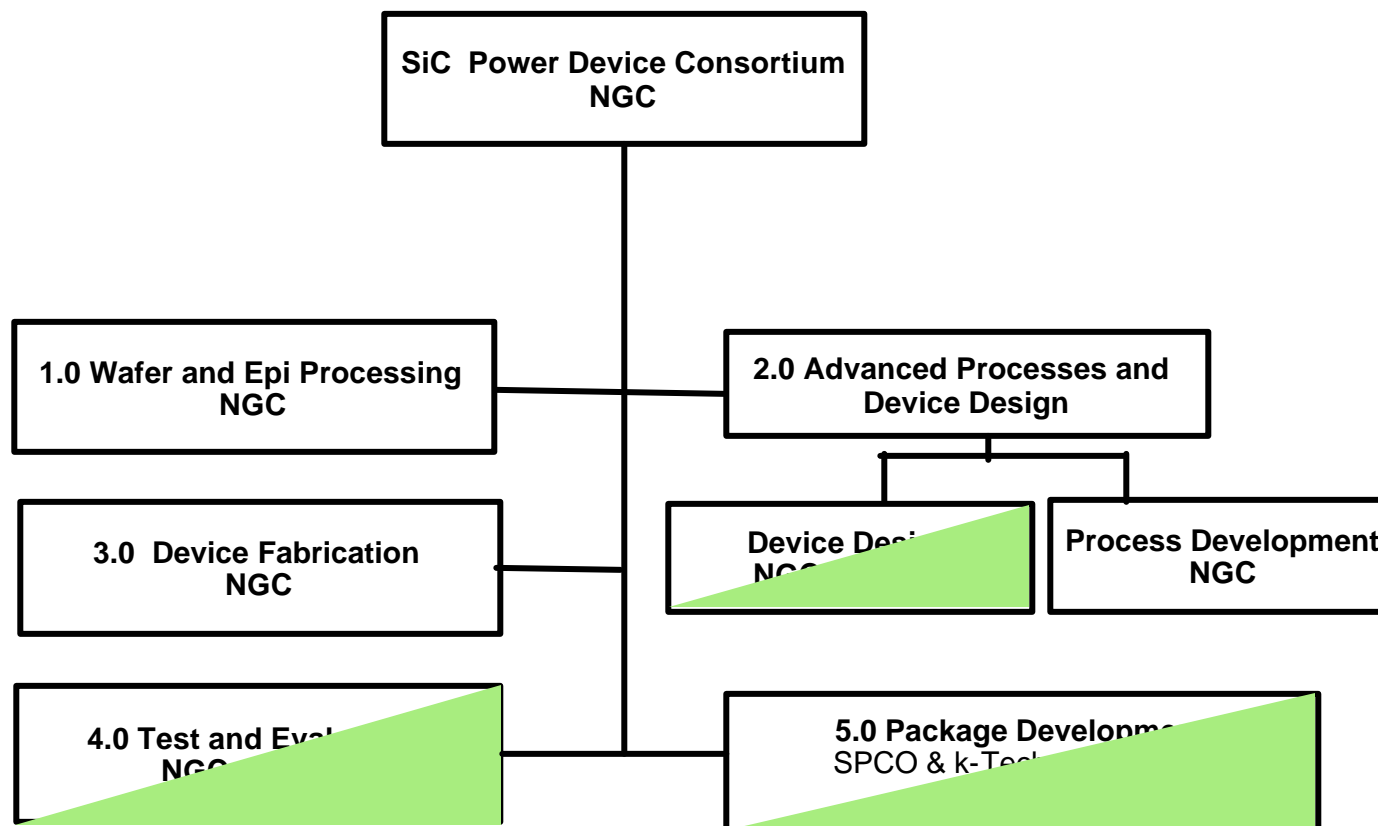
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Program Organization



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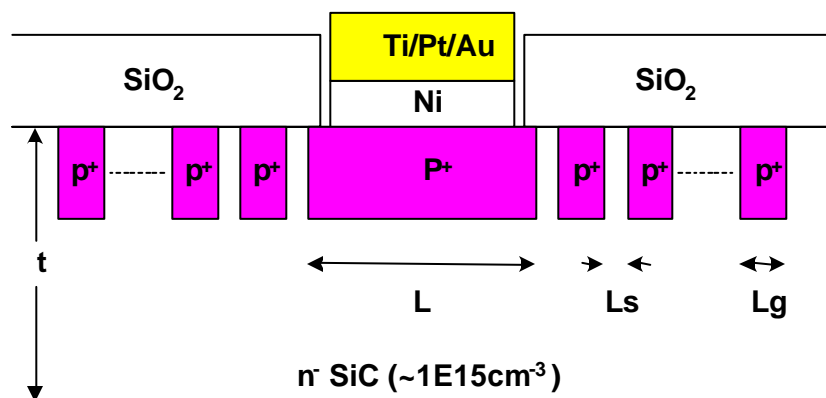
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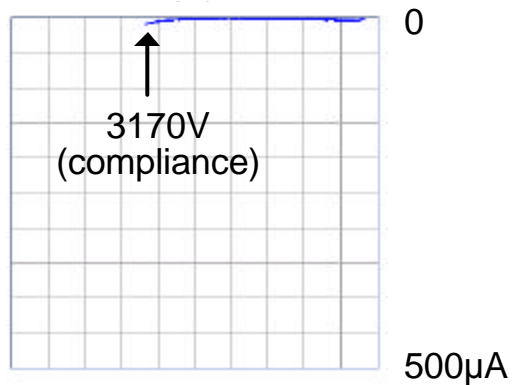


Edge Termination

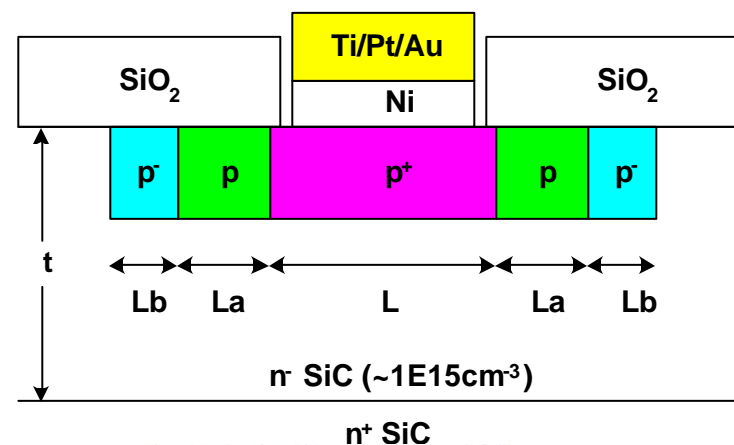
GR (15 rings max)



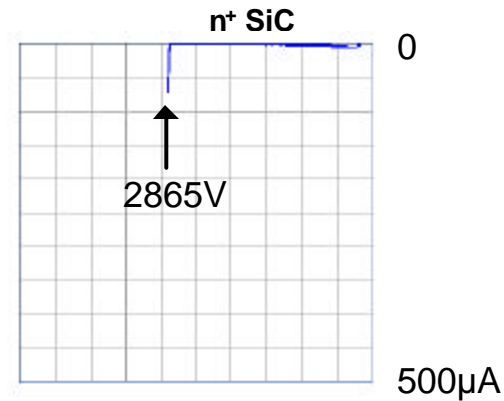
1mm GR Diode



JTE (2 zone)



1mm JTE Diode



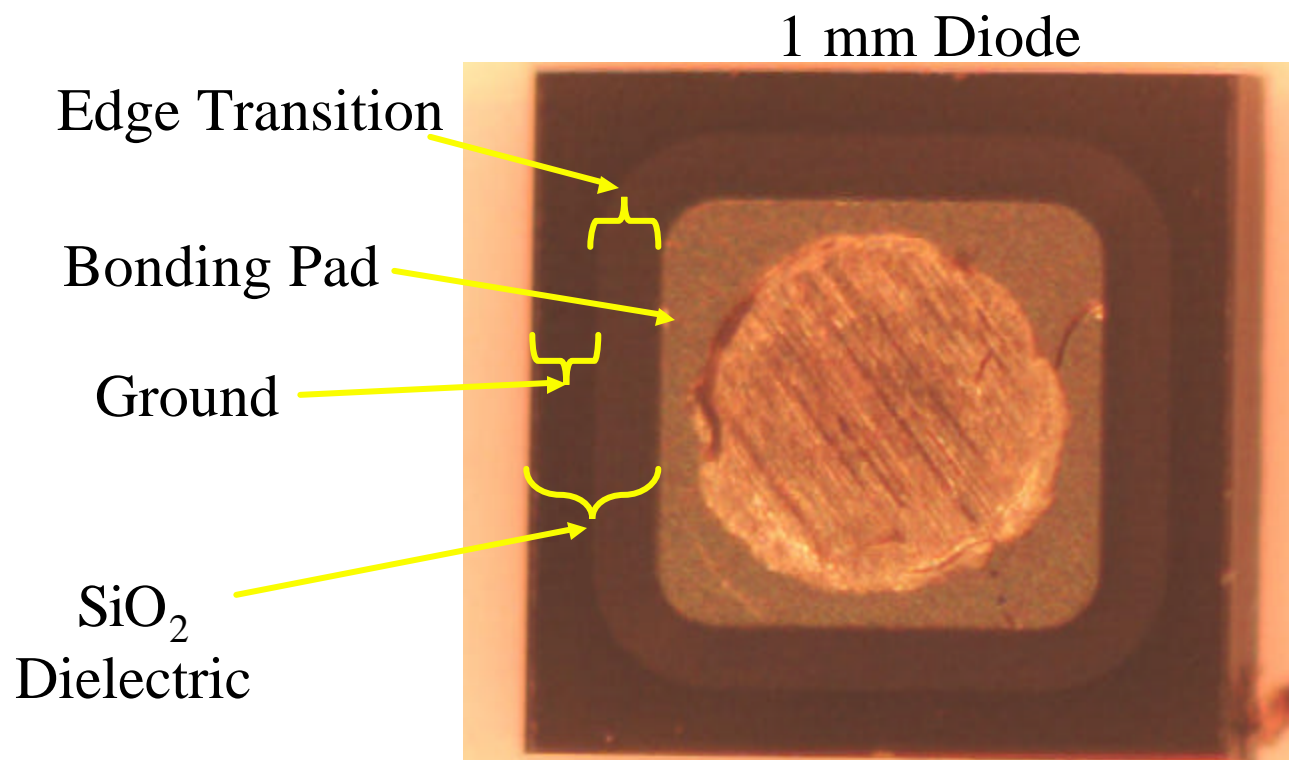
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High Voltage Diode Edge Termination



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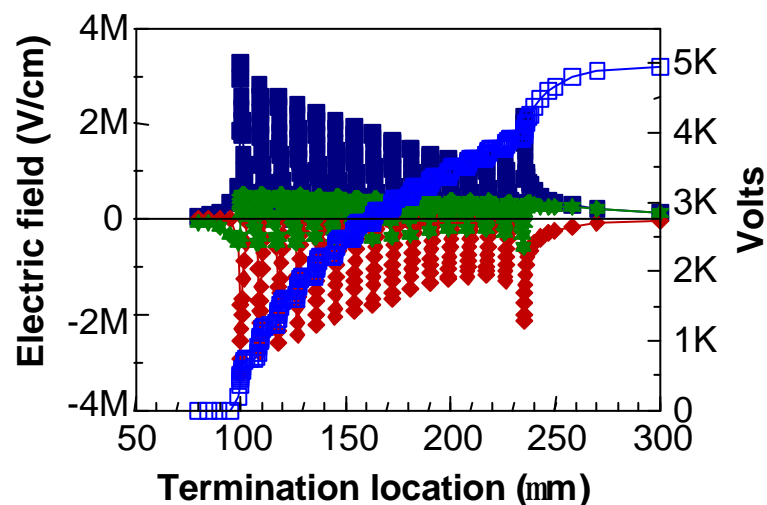


Multizone JTE reduces Surface fields by Order of Magnitude



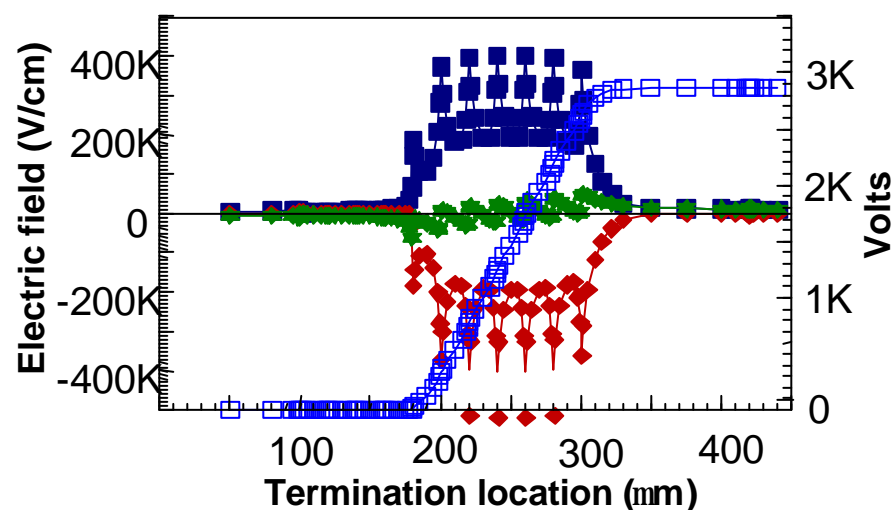
Surface field and voltage
for 15 field rings

Peak surface Field = $4E6$ V/cm



Surface field and voltage
for a 10 zone JTE

Peak surface Field = $4E5$ V/cm



□ Voltage ♦ Surface E Field ★ Normal E Field ■ E Field

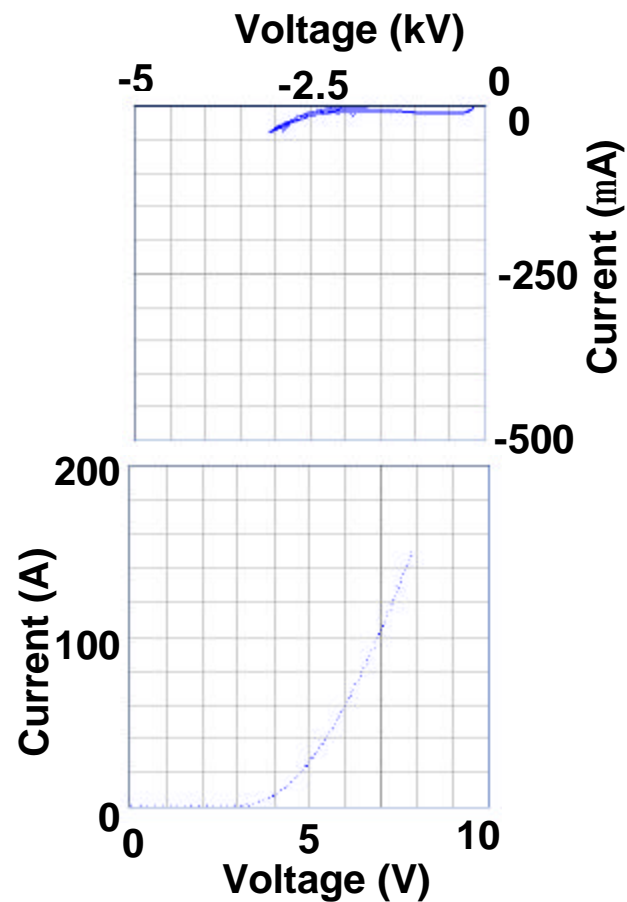
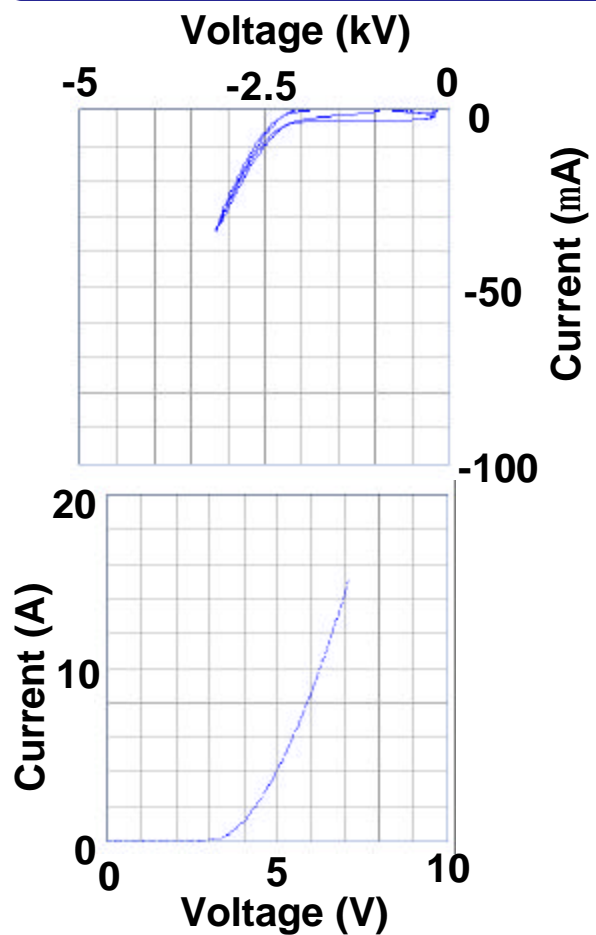
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Single Diode achieves >3KV and >10A Assembly achieves >3KV & >100A



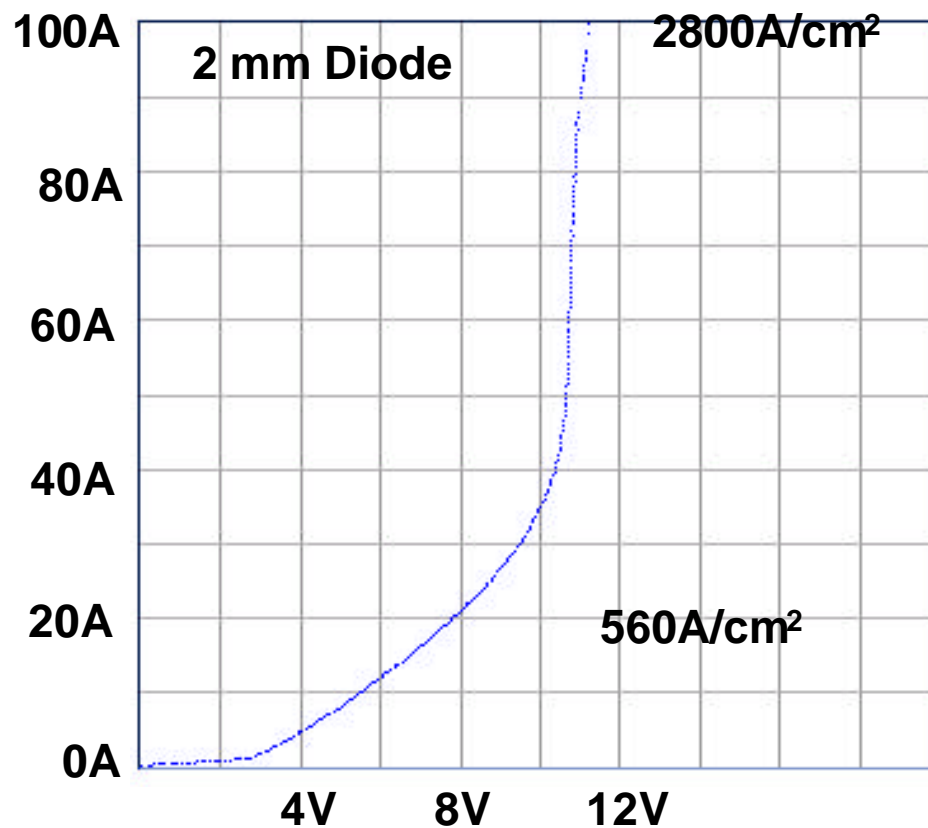
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SiC is incredibly rugged



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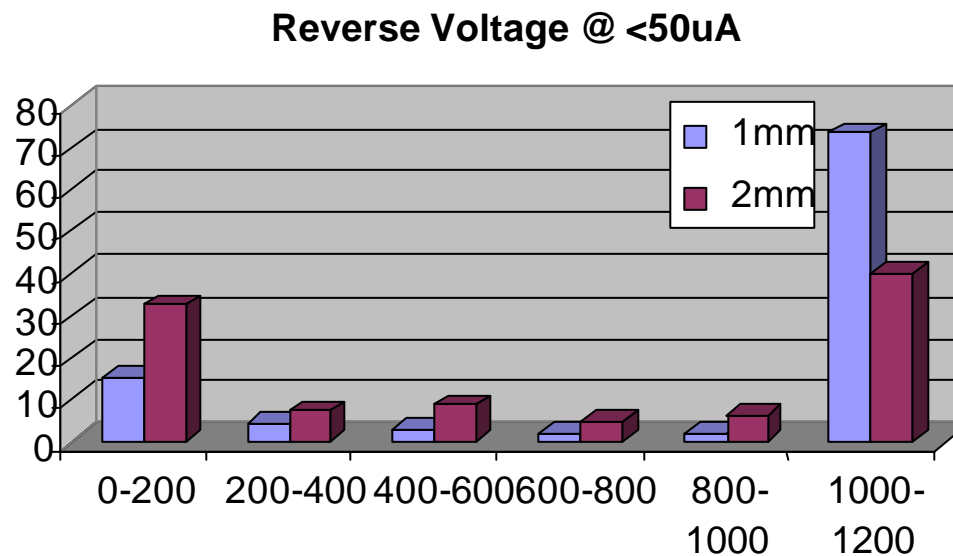
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Diodes show >70% yield



- Strong dependence on epi quality
- Reasonable (40%) yields even at 2 mm

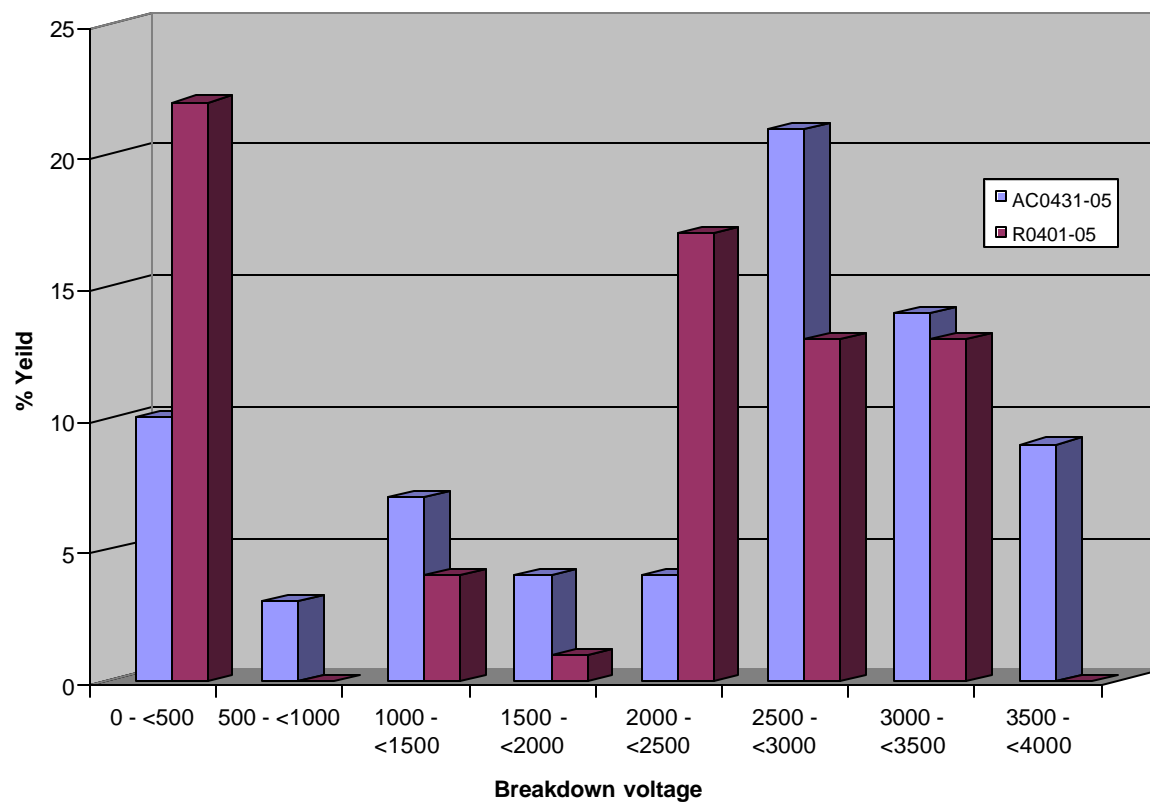
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High Voltage Diode Yield



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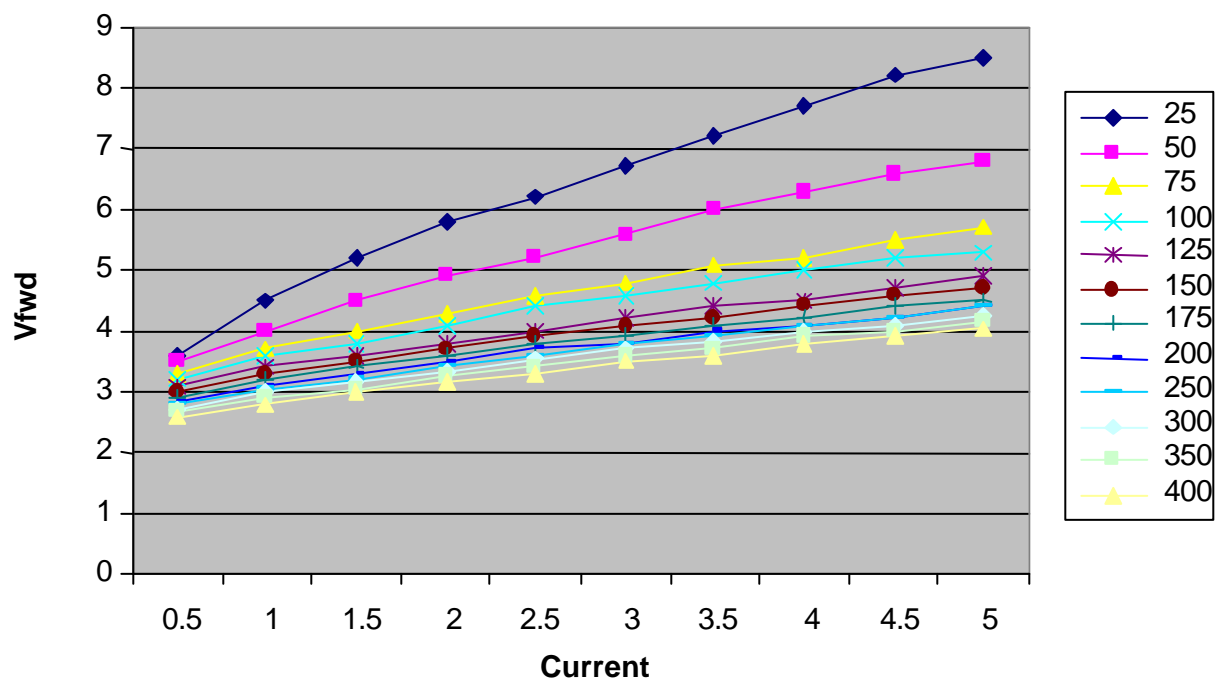
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Forward drop decreases with temperature



Fwd V vs. I as a function of Temperature



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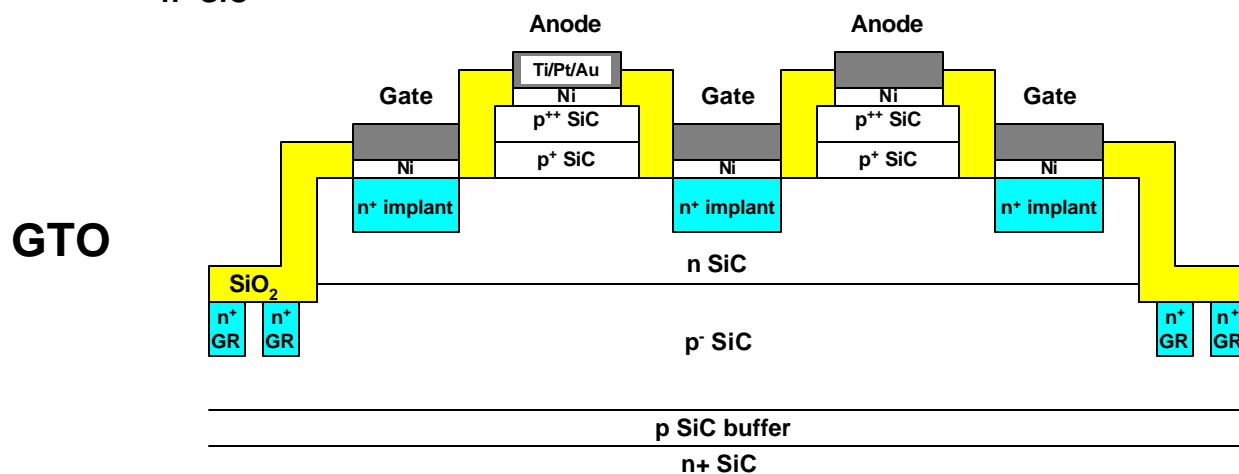
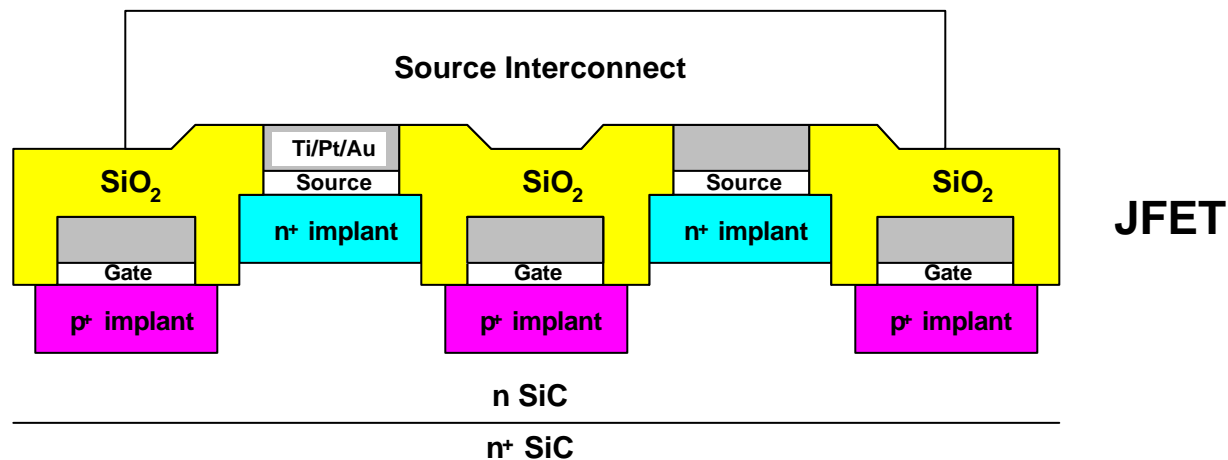
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JFET & GTO



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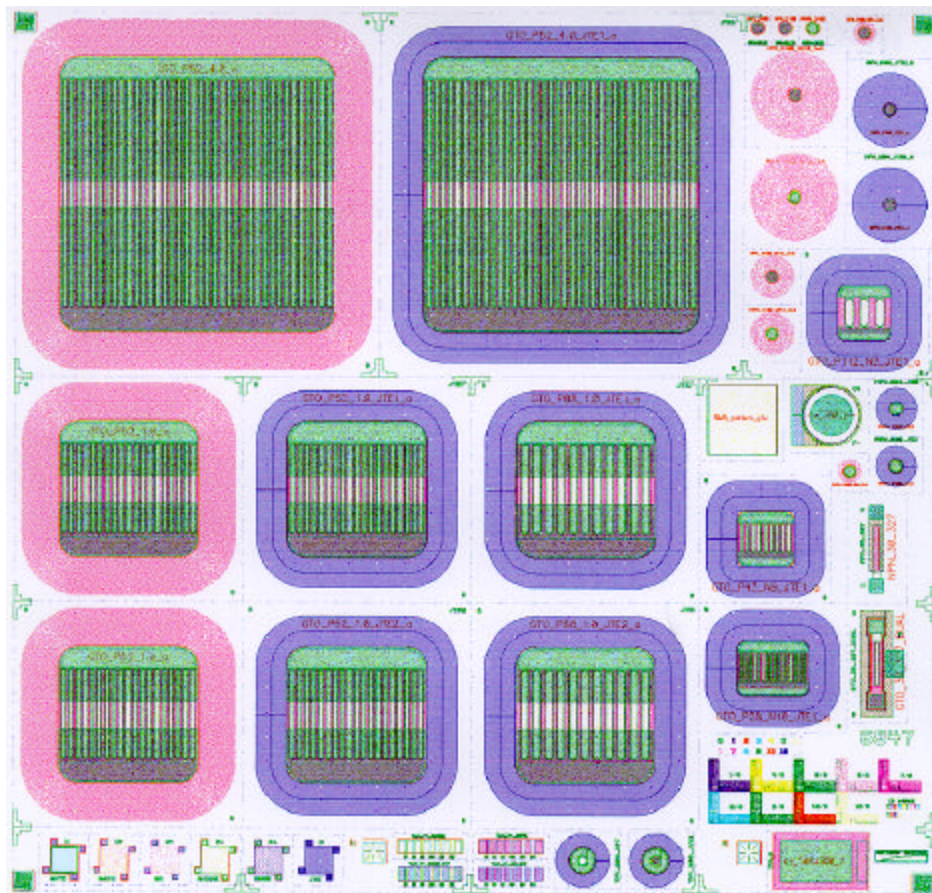
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GTO Device Development



- GTO anode finger designs:
- GTO edge terminations:
 - 20 GR
 - 20 zone JTE
- pnp and npn BJT test structures
- pnpn and npn test diodes with GR and JTE edge terminations
- PCMs for evaluation of:
 - Electrical properties of top 4 layers
 - Ohmic contacts
 - Electrical activation of implants
- Area for SIMS analysis

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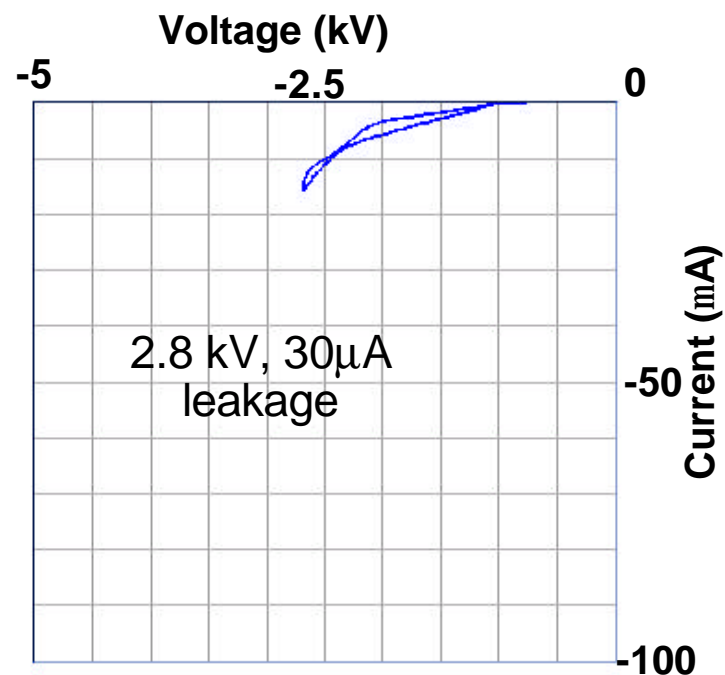
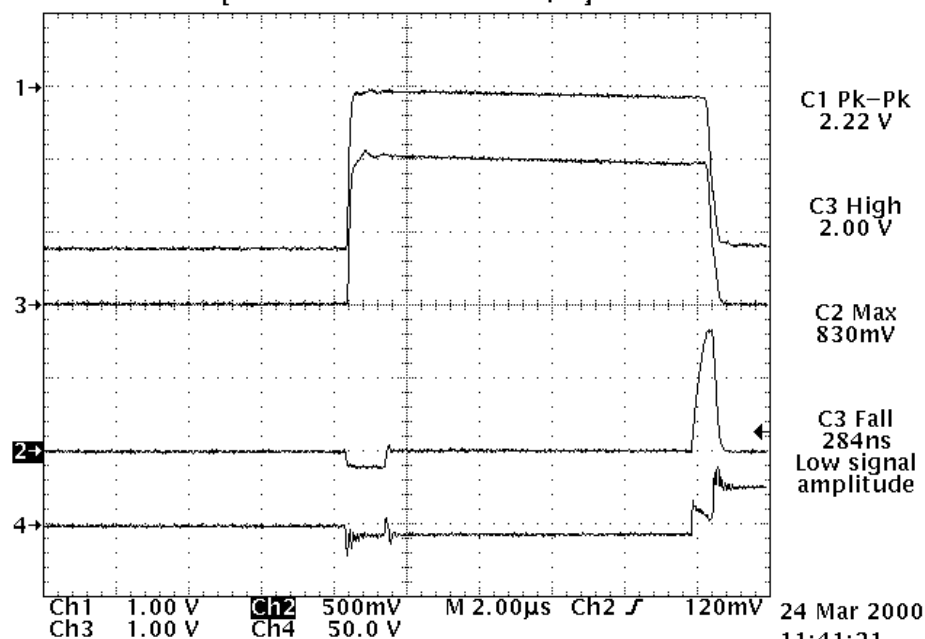
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1mm GTO achieves 20A cell 2mm GTO achieves 2.8kV



Tek Run: 50.0MS/s Average



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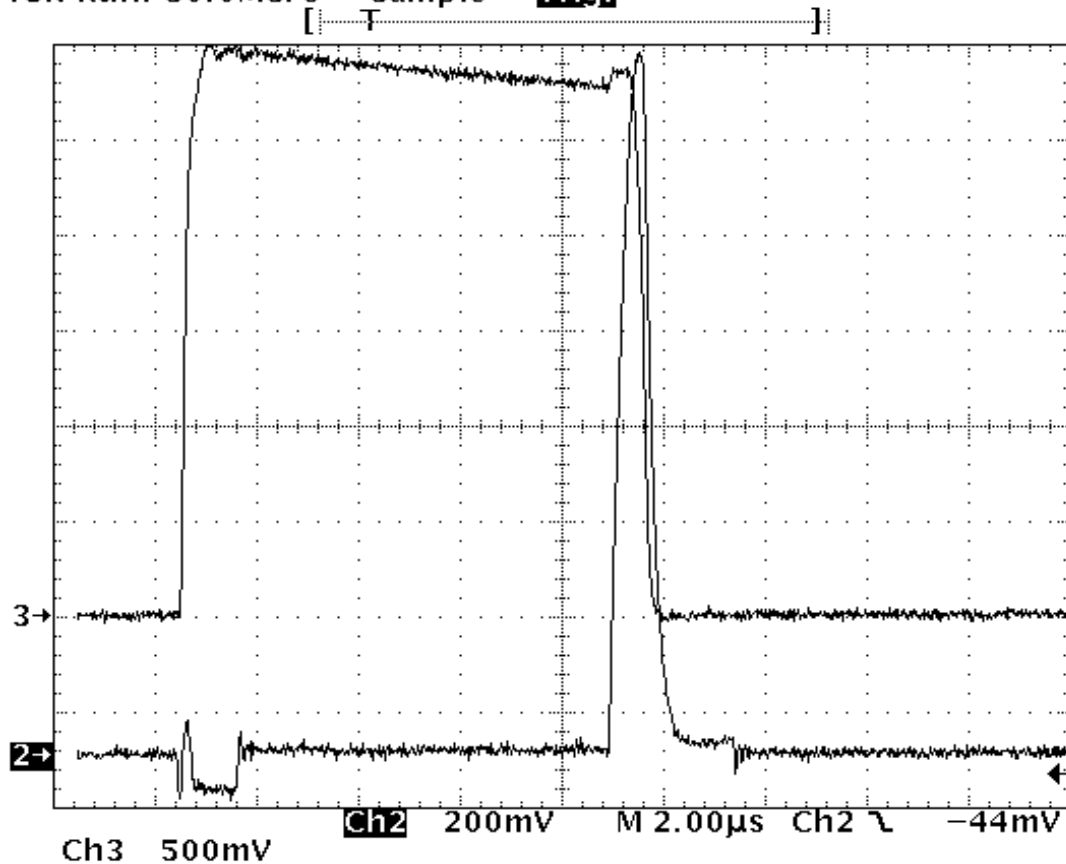
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30A assembly



Tek Run: 50.0MS/s Sample Trig



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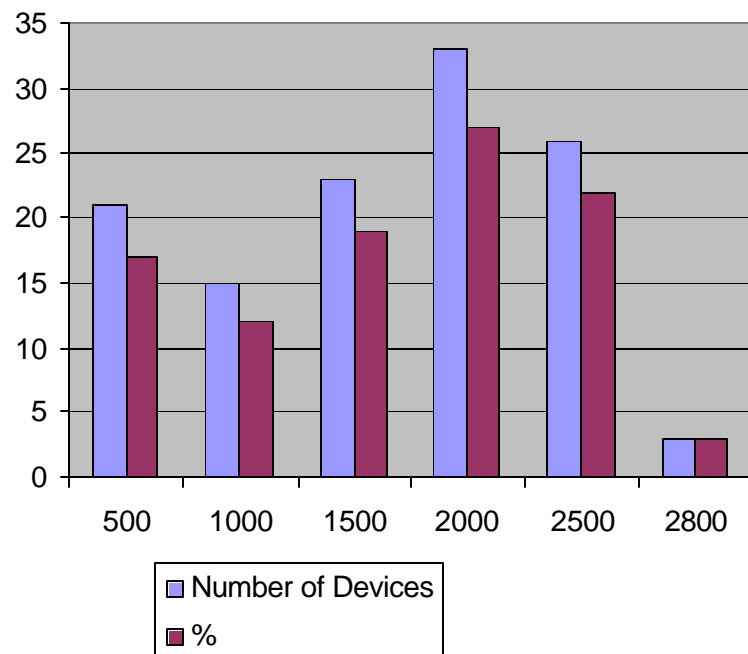
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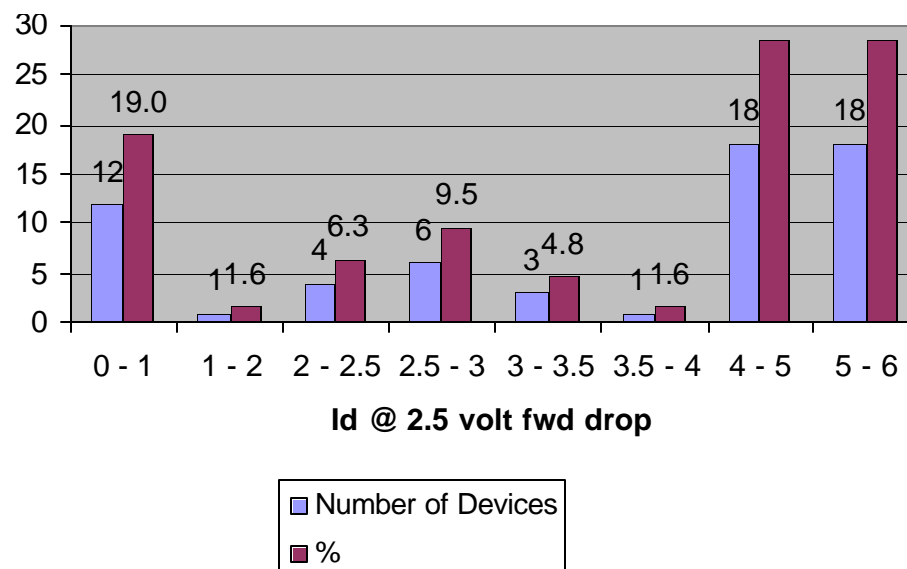
GTO Yields ~ 25% @ 2 kV JFET Yields >50% @ 4A



30 micron GTO



JFET



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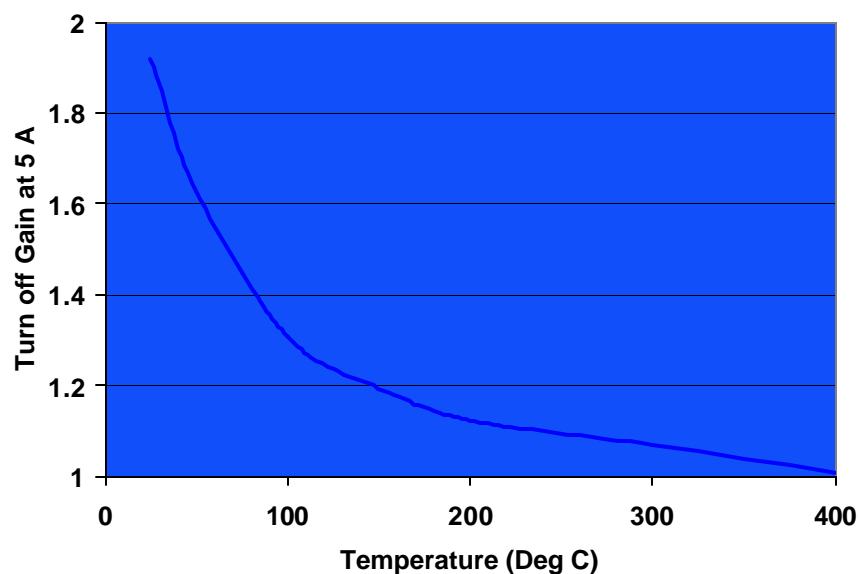
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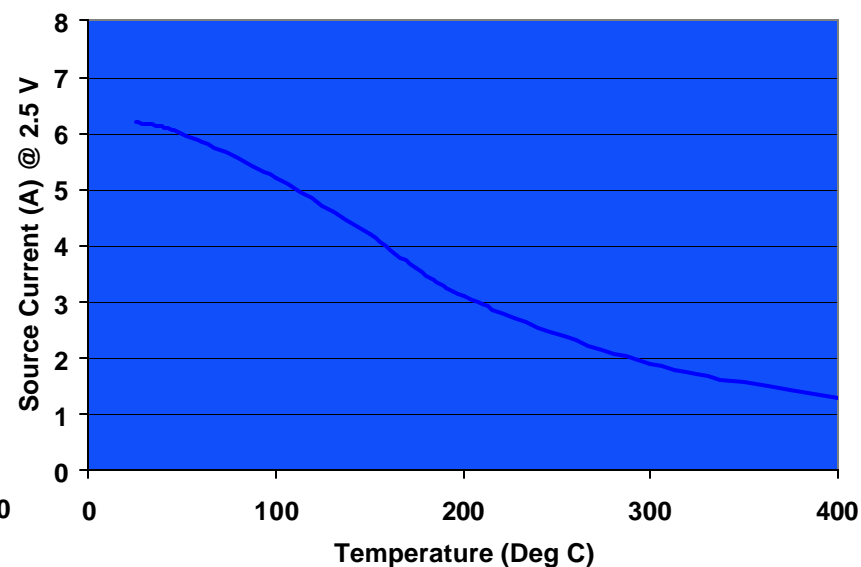


Turn off Characteristics for JCT

GTO Turn off Gain



JFET Current



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Device Summary



- Phase I and Phase 2 device goals exceeded

Phase 1

- Diode: 2A cells, 30A, 2kV
- GTO: 2A cells, 30A, 2kV
- JFET: 1A cells, 5A

Phase 2

- 10 A cell, 100A, 3kV
- 10A cell, 30A, 2.8 kV
- 2.5A cell, 25A

- Demonstrated 30A JCT
- Yields for 1mm above 50%,
- Yields for 2mm are encouraging- >30%

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SPCO is packaging JCT



Design Specifications

- **Current: 200 Amperes**
- **Voltage: 3kV**
- **Temperature range: RT - 250C**
- **Power density up to 1250 watts/cm²**
- **Device Specs:**
 - **RT:**
 - GTO - 2mm x 2mm/ 20Amp @5 Volts
 - JFET - 1mm x 1mm/ 3Amps @ 2 Volts
 - **250C**
 - GTO - > 20Amp @5 Volts
 - JFET - 1.0Amps @ 2 Volts

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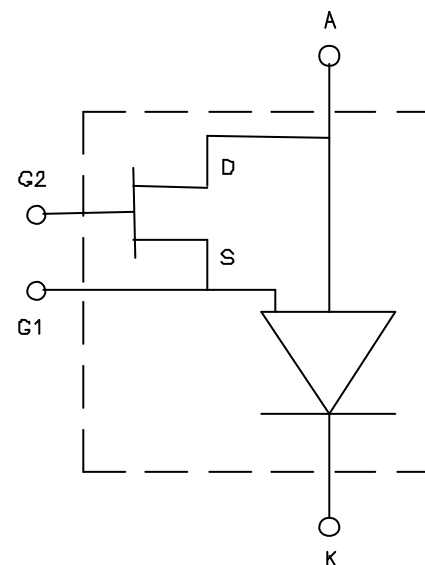
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JCT Critical Design Issues

- High GTO power density:
20A/5V/ Area= .04 cm²/50% Duty
→ 1250 Watts/cm²
- High temperature
- Inductance in gate ckt.
- Resistance in gate ckt.
- Height variations from device to device can result in large mechanical stress when paralleled.
- High E-field on top side of GTO cell (3kV across 220 mm gap)



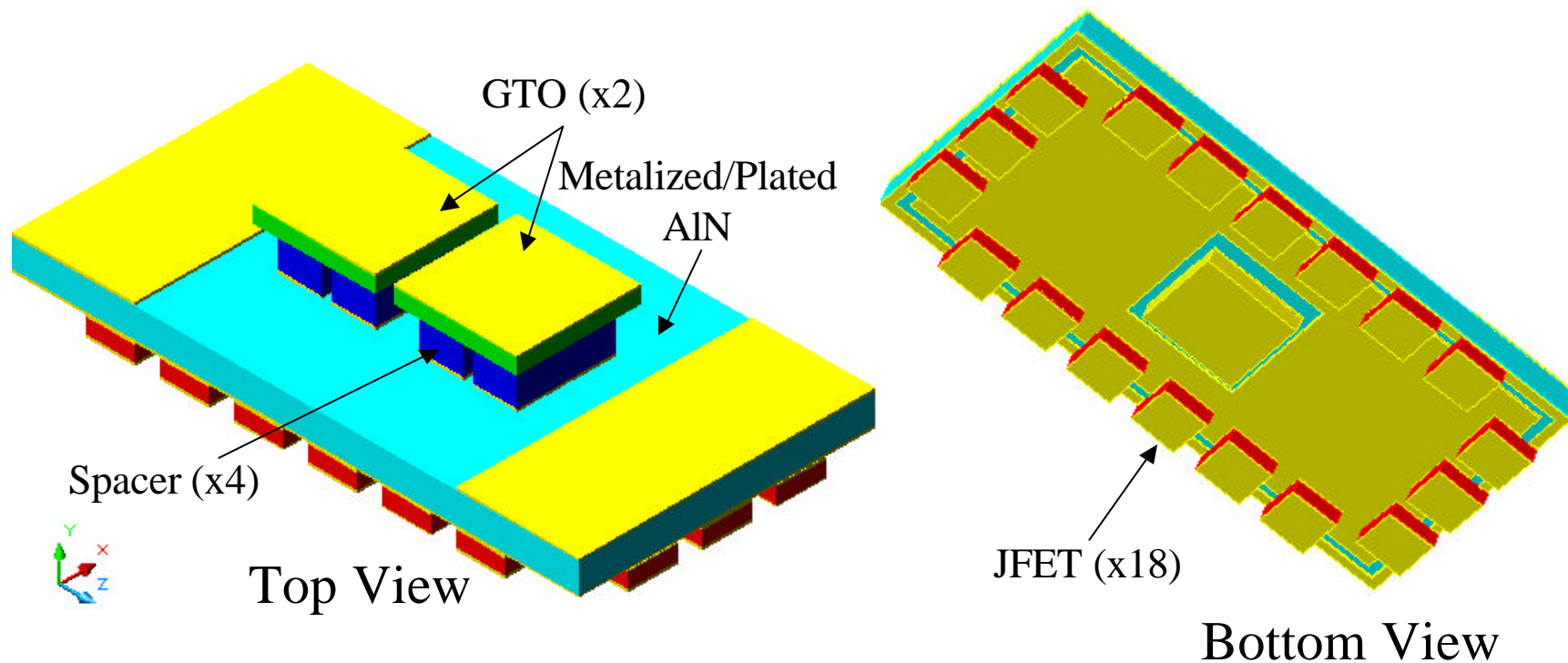
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40 Amp JCT Module



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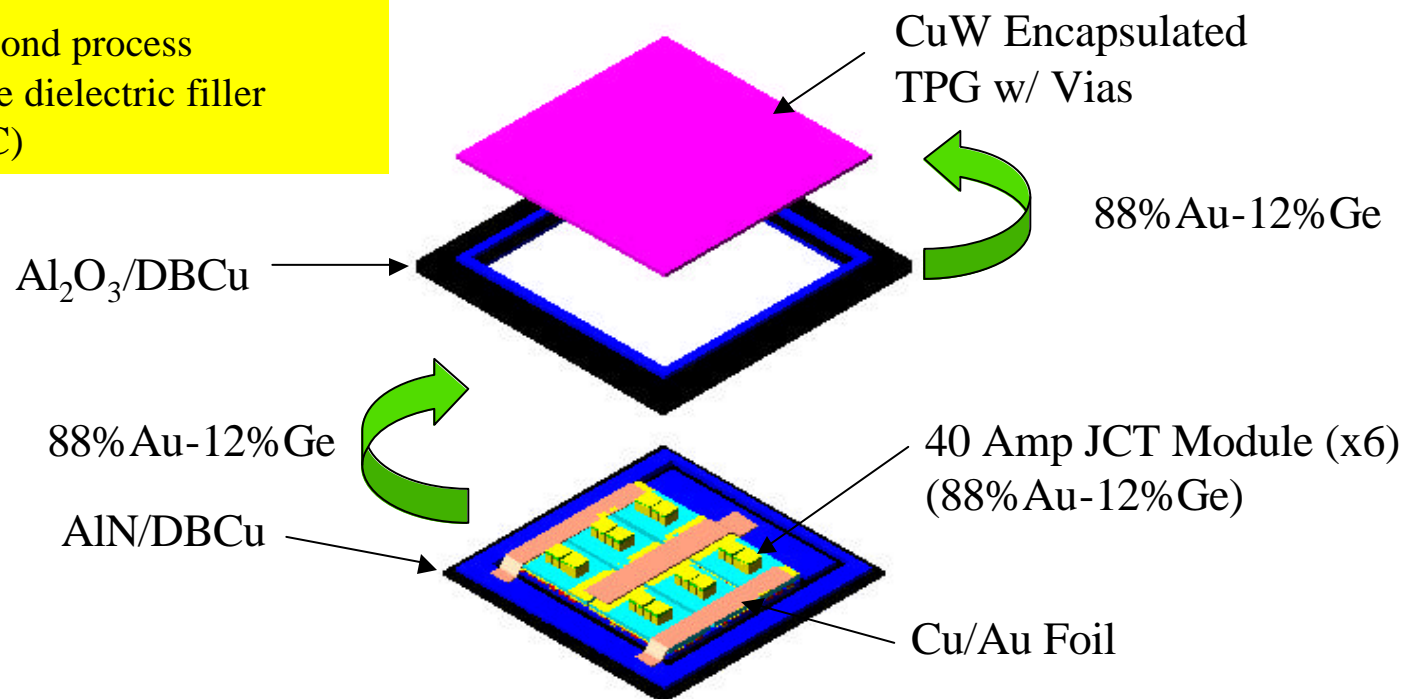
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200 Amp Package Design



- Dimension: 1.440"(36mm) x 1.440"(36mm) x 0.200"(5mm)
- 12 GTOs
- 108 JFETs
- 3 stage Au-Ge bond process
- Zirconia Silicate dielectric filler (225v/mil, >500C)



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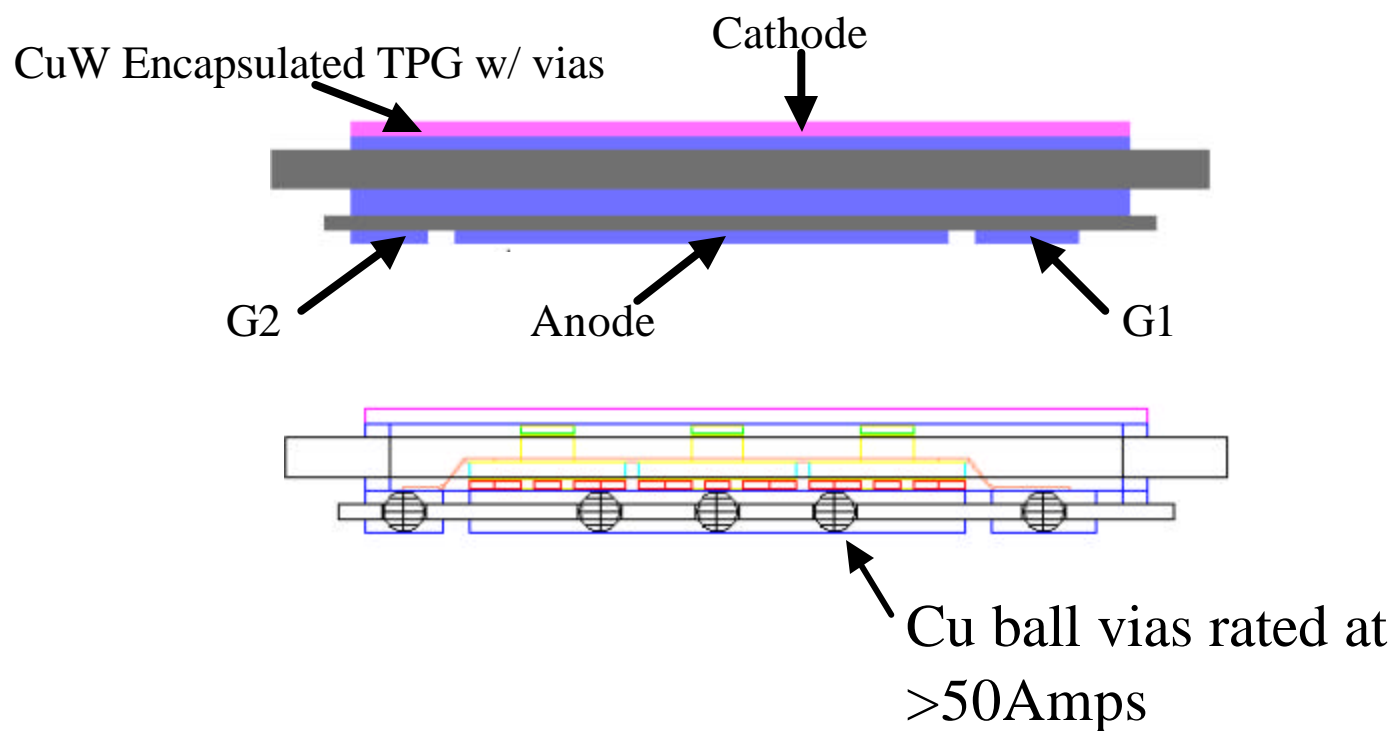
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200 Amp JCT Package

(Continued)



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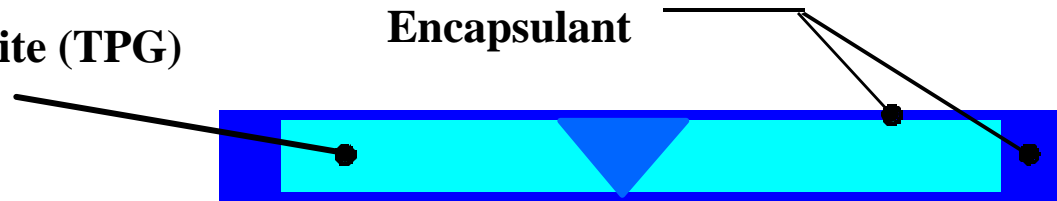


TPG enhances thermal conduction



Thermal Pyrolytic Graphite (TPG)
 $K_{xx}=K_{yy} = 1700 \text{ W/mK}$
 $K_{zz}=10 \text{ W/mK}$

Encapsulant



- **Material Concept**

- The TPG Insert Provides a High Thermal Conduction Path
- The Encapsulation Material Provides Tailorable CTE Mounting Surface
- There Is Negligible In-plane Structural Coupling Between the TPG and Encapsulant

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TPG Properties

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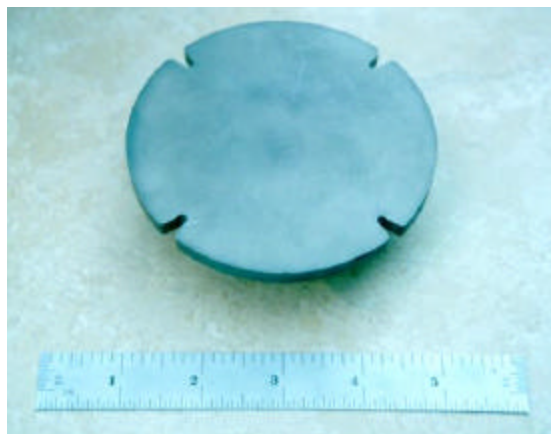
TPG Encapsulation Demonstration



TPG Insert



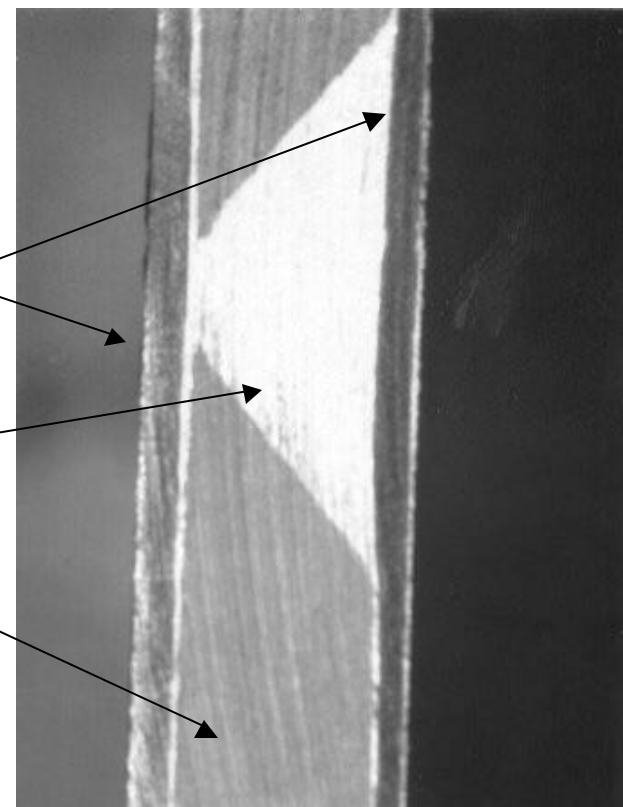
AlSiC/TPG Heat Spreader



AlSiC

Al Via

TPG



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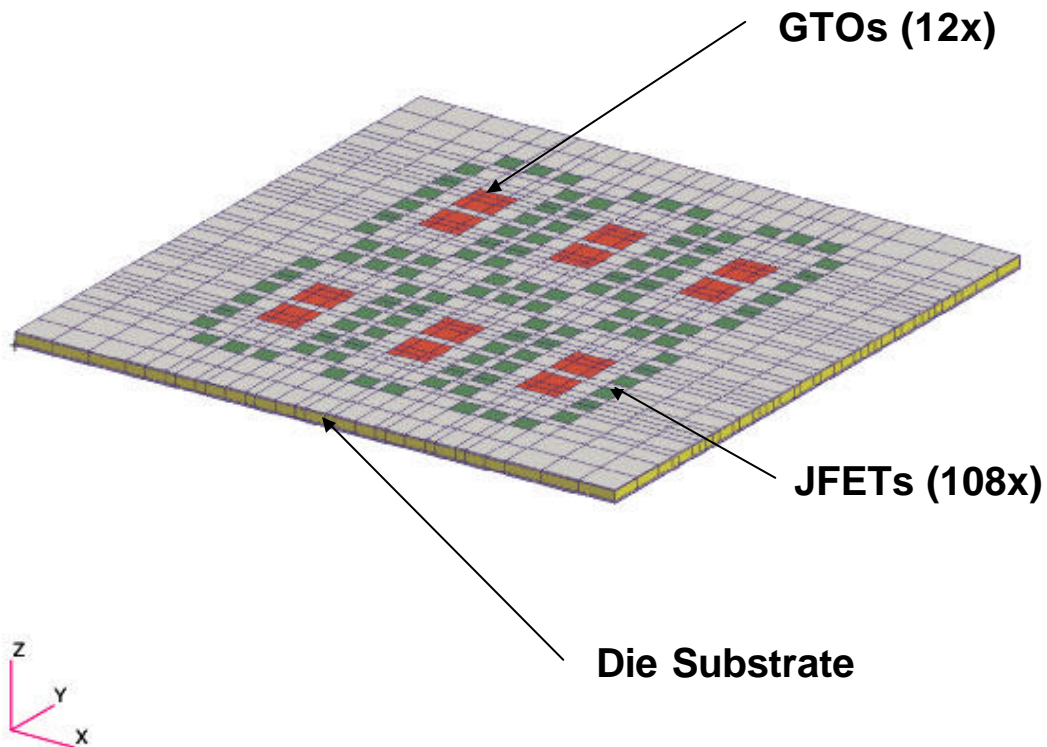


200 Amp Package Thermal Analysis



- Finite Element Model

- ABAQUS Finite Element Code
- 3D Heat Transfer Element
- 4800 Nodes
- 3393 Elements
- Processed on HP C3000 Platform



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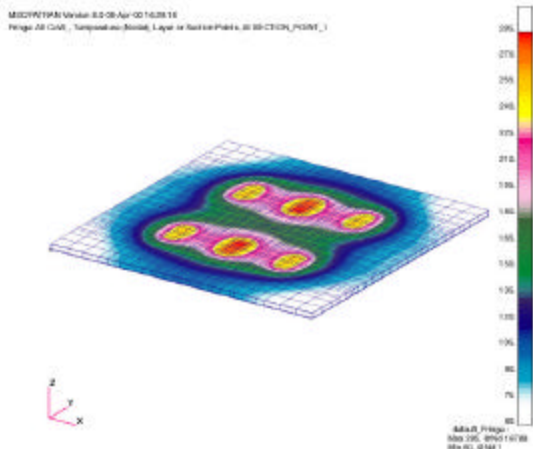


Thermal Analysis



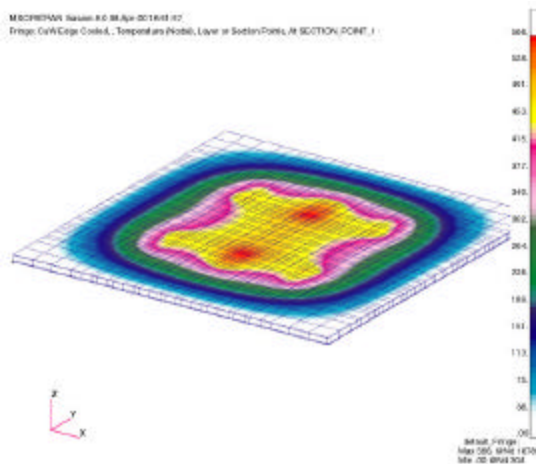
Case 1

- Back Surface Convection
- Material - CuW
- Thickness - 0.6mm
- Maximum Temperatures
 - 285°C at GTO
 - 235°C at JFET



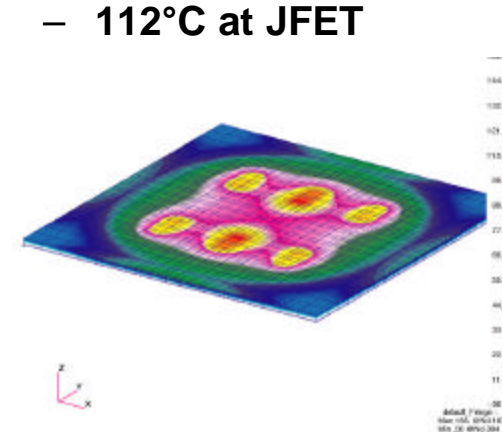
Case 2

- Circumferential Cooling
- Material - CuW
- Thickness - 0.6mm
- Maximum Temperature
 - 566°C at GTO
 - 515°C at JFET



Case 3

- Circumferential Cooling
- Material - CuW
- Encapsulated TPG
- Thickness - 0.6mm
- Maximum Temperature
 - 169°C at GTO
 - 112°C at JFET



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Summary



- Megawatt demonstrates enhanced thermal and electrical properties of SiC
- As substrates are improved larger devices will be feasible
- Single Devices achieve $>500\text{W/cm}$, $>20\text{A}$, $>3\text{kV}$
- Advanced packaging concepts will integrate a 200A package with advanced TPG materials
- CHPS will provide a near term demonstration

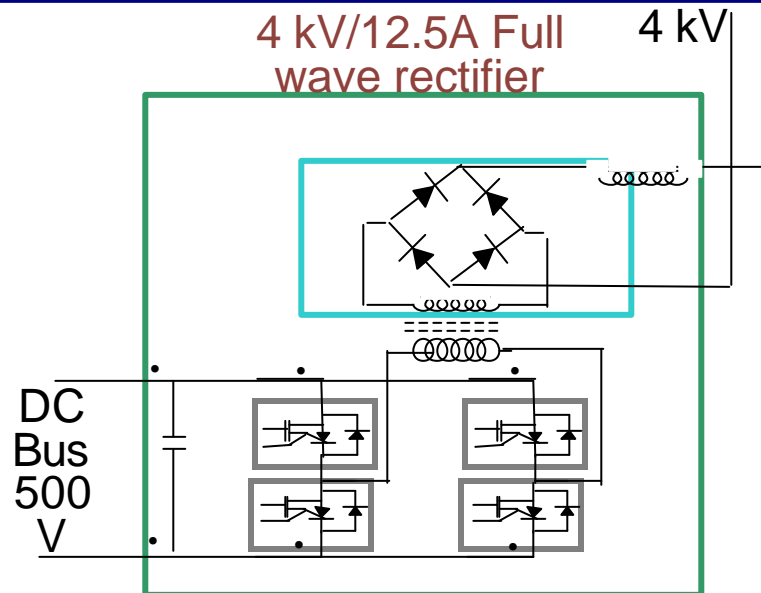
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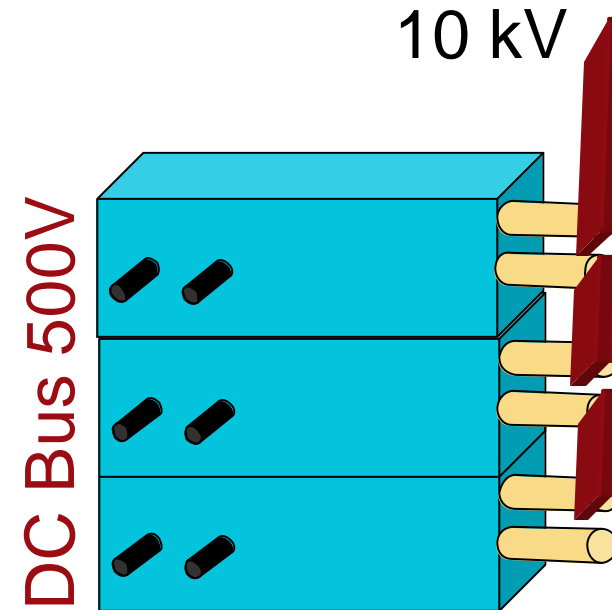
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CHPS Air cooled, upgradable modules deliver 0.2 sec pulse at 150 kW



Module holds 500V/100A H Bridge
with four 100A sandwiches
400C junction temp. on switches
and 250C on rectifier 100 kHz



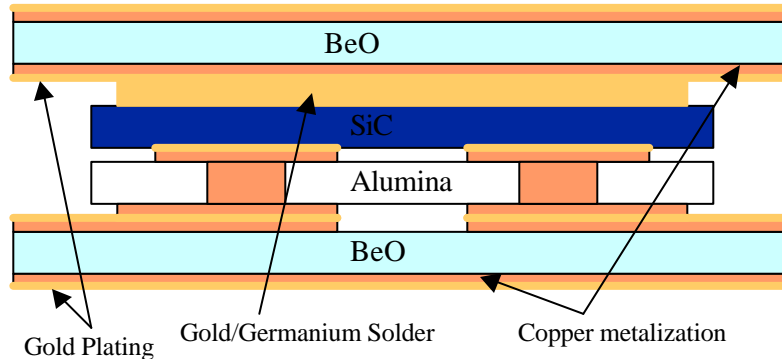
Three 50 kW modules in
series to achieve 10kV
and 150kW for 3
modules in series

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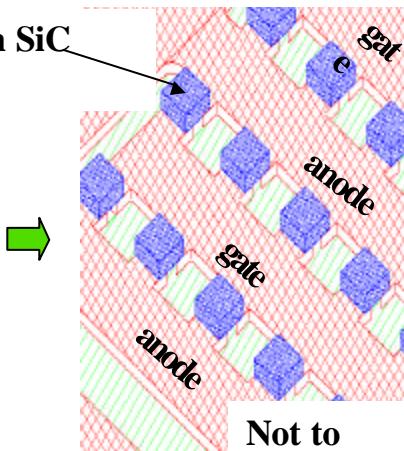




First samples of Substrates using BeO for both Switch and Rectifier received



1x1 mm SiC devices



Not to scale

- **We have settled on BeO as the substrate material**
 - AlN process needs more development--- beyond CHPS
 - In addition to better yields, this drove the selection of 1x1mm devices.
- **Sandwich Implementation indicates basic approach works**
 - 100A Switch Design in Progress
 - Alumina Feedthrus production process optimized

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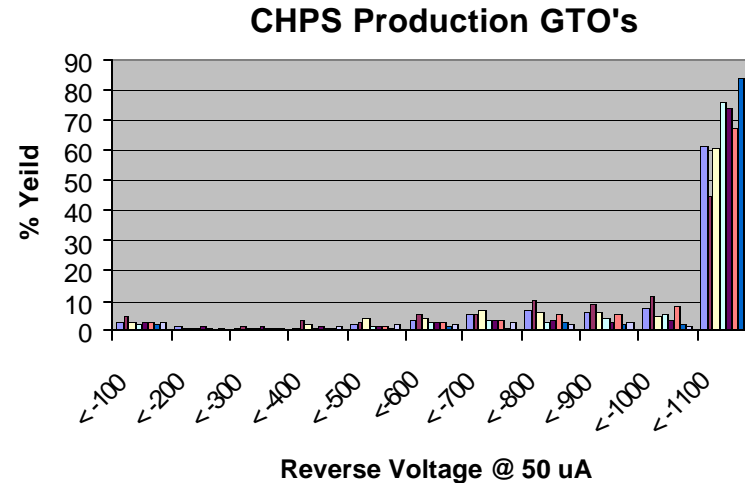
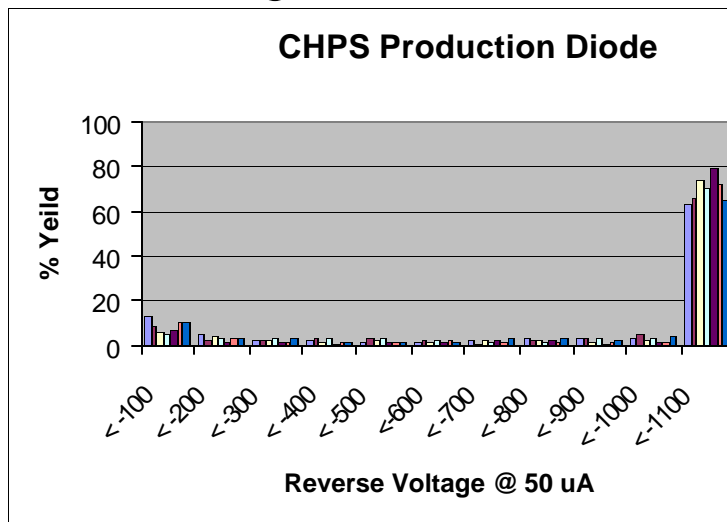


Device Yields have been Good



Low Voltage Diode Yield - 70%

GTO Yield - 53%

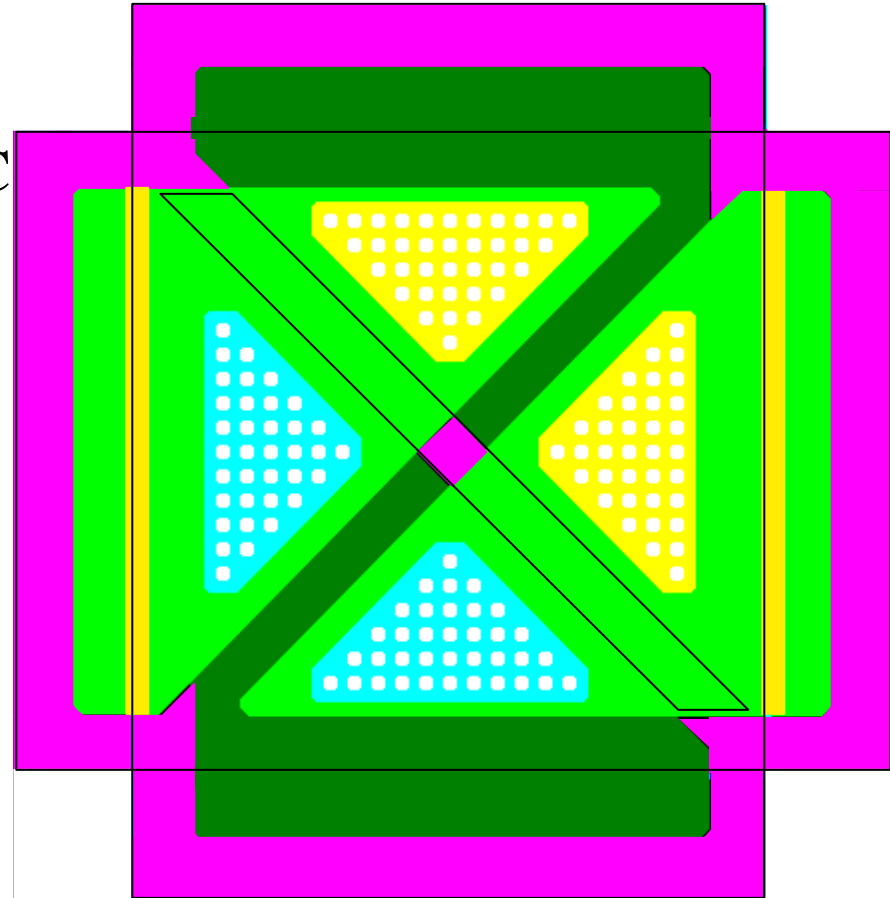
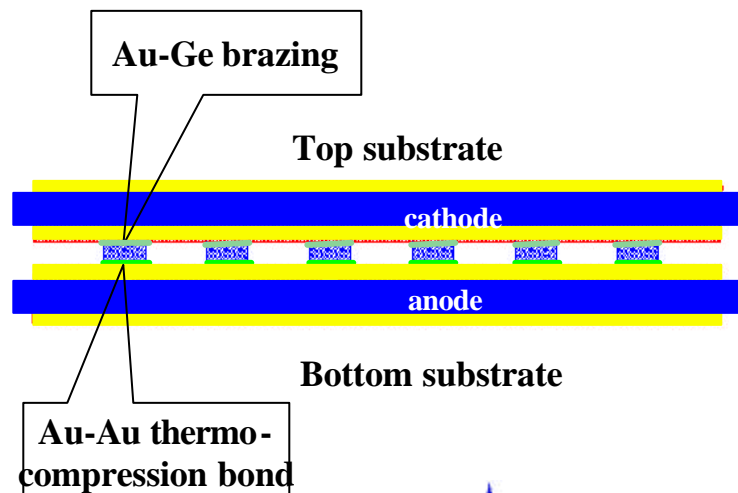
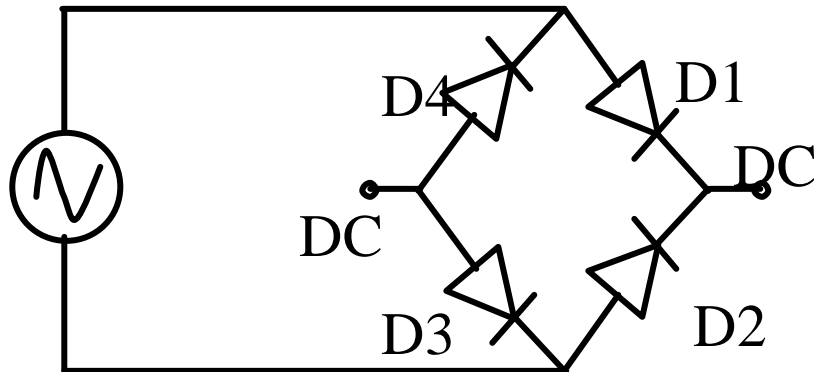


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Rectifier



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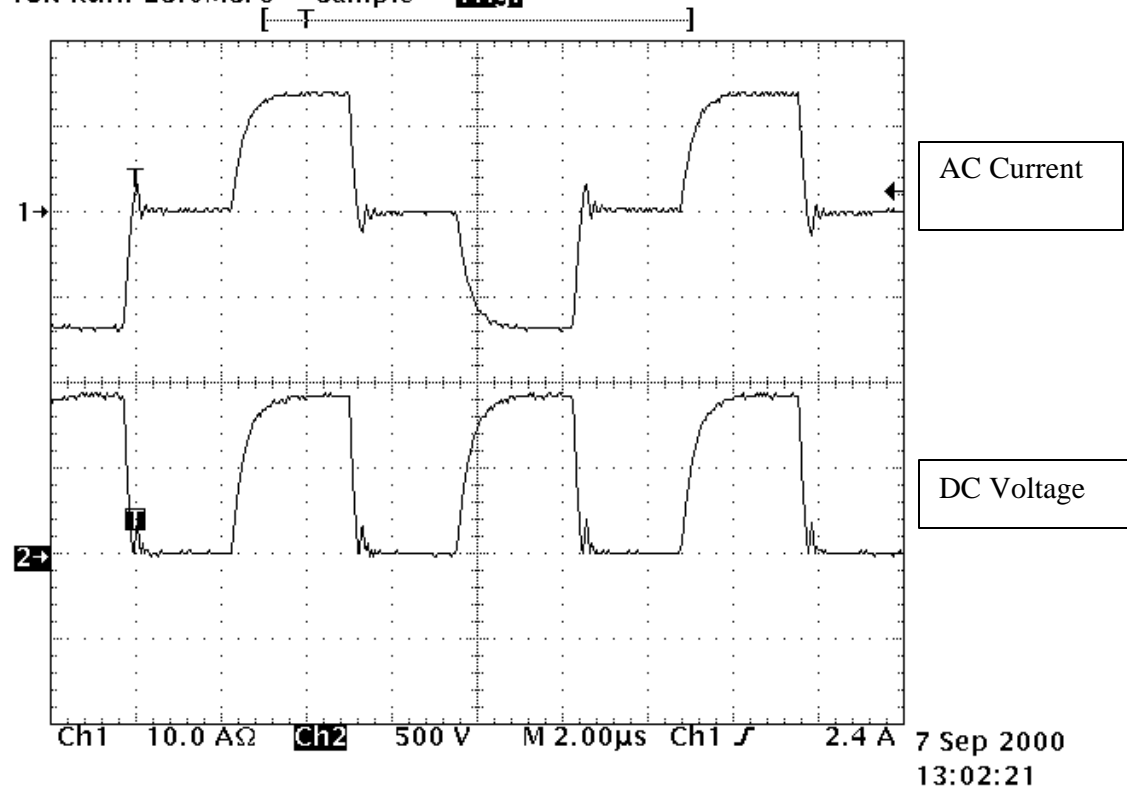




Rectifier - 14A @ 1kV & 100kHz



Tek Run: 25.0MS/s Sample **Trig?**



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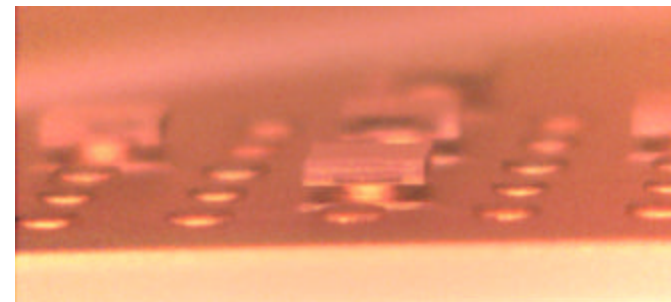
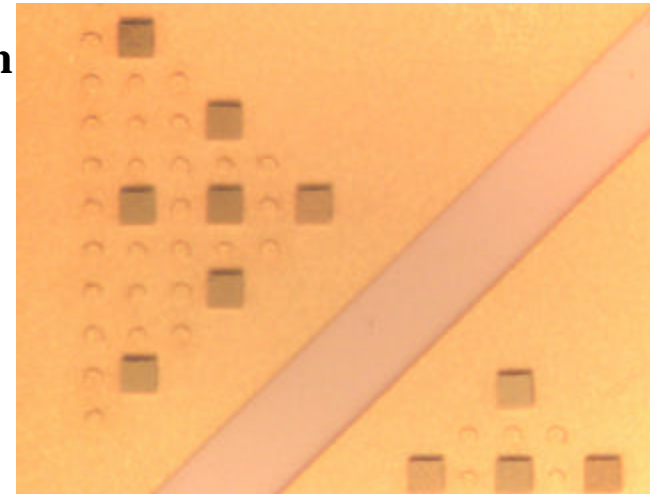
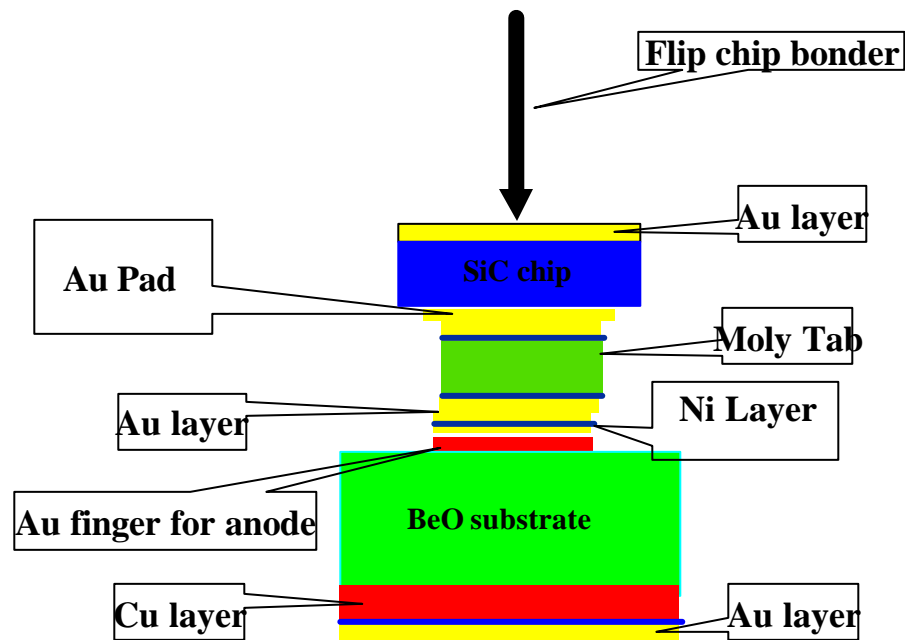




Thermo-compression Bonding of Die



- Process: 380°C for 120 sec at 3-6 kg in air
- High temperature bond: Au-Au solid diffusion



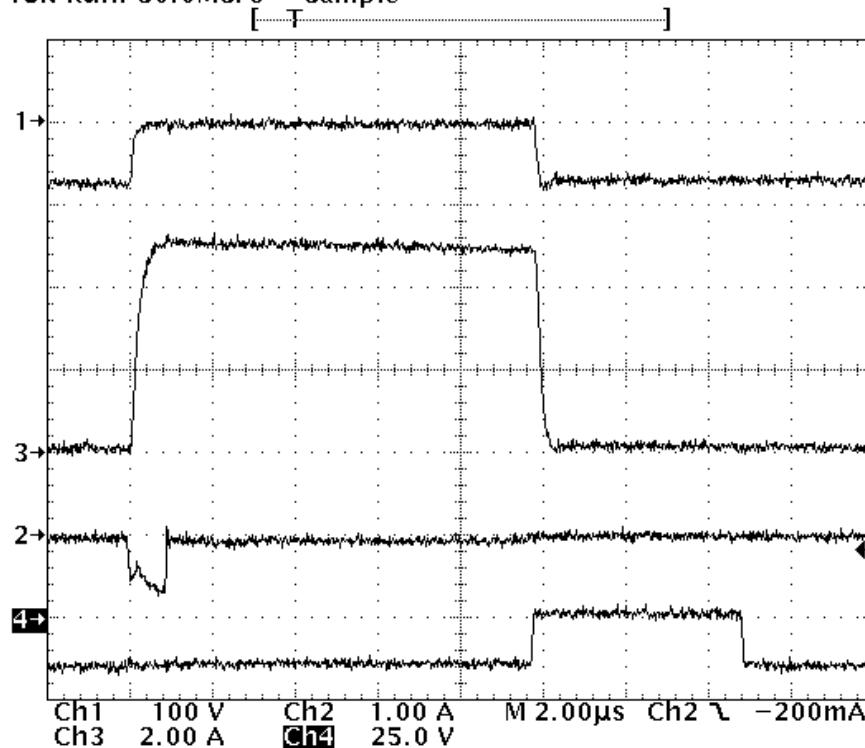


Switch Sandwich



Switch #1 - 5A at 400V

Tek Run: 50.0MS/s Sample



Switch Voltage

C3 High
5.04 A

Switch Current

C3 Fall
228ns

GTO Gate Current

JFET Gate Voltage

5 Sep 2000
13:17:23

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